

Search Notes  	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/773,366	SAITO ET AL.
	Examiner	Art Unit
	John S.. Chu	1752

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
430	157,171	7/20/87	JSC
430	182		
548	146		